



Attorney Docket SEL 238

**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
)  
Hiroki et al. )  
)  
Serial No.: 09/776,472 )  
)  
Filed: February 2, 2001 )  
)  
For: Thin Film Formation Apparatus And )  
Method Of Manufacturing Self-Light-)  
Emitting Device Using Thin Film )  
Formation Apparatus )  
)  
Art Unit: 1762 )  
)  
Examiner: M. Cleveland )  
)  
  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
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March 8, 2004

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 3/8/04

Signature

Date

**AMENDMENT D**

Sir:

In response to the Office Action of November 6, 2003, a one month extension of time being submitted herewith, please amend the above-identified application as follows: